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Item Type	Article
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Citation	Surface-Controlled Metal Oxide Resistive Memory 2015:1 IEEE Electron Device Letters
Eprint version	Post-print
DOI	10.1109/LED.2015.2493343
Publisher	Institute of Electrical and Electronics Engineers (IEEE)
Journal	IEEE Electron Device Letters
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Download date	2024-03-13 07:14:33
Link to Item	http://hdl.handle.net/10754/581765

Surface-Controlled Metal Oxide Resistive Memory

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Abstract—To explore the surface effect on resistive random-access memory (ReRAM), the impact of surface roughness on the characteristics of ZnO ReRAM were studied. The thickness-independent resistance and the higher switching probability of ZnO ReRAM with rough surfaces indicate the importance of surface oxygen chemisorption on the switching process. Furthermore, the improvements in switching probability, switching voltage and resistance distribution observed for ReRAM with rough surfaces can be attributed to the stable oxygen adatoms under various ambience conditions. The findings validate the surface-controlled stability and uniformity of ReRAM and can serve as the guideline for developing practical device applications.

Index Terms—ZnO, oxygen chemisorption, surface roughness, resistive random-access memory.

I. INTRODUCTION

Surface effect is a double-edged sword for the device application of metal oxide. Surface effects resulting from the gas molecules chemisorption-induced surface band bending significantly influence electronic and optoelectronic properties of metal oxide devices [1]. For example, benefited from the surface band bending of the ZnO due to the chemisorbed O₂ molecules, which is around 1.53 eV, nanostructured gas sensors and photodetectors have shown remarkable device sensitivity [1]. On the other hand, this surface effect can be detrimental to some device applications, such as oxide thin film transistors because of surface effect-induced electrical instability [2].

Recently, metal oxide-based resistive random-access memory (ReRAM) for the non-volatile memory has captured great attention due to the excellent reversible resistive switching. Among the metal oxides currently had being explored for the development of ReRAM, ZnO has been demonstrated to be a potential candidate. ZnO is an n-type wide bandgap semiconductor and is highly transparent in the visible spectral region. Its conductivity can be modulated by suitable impurity

This work was supported by the Chung-Hua Institution for Economic

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Digital Object Identifier xx.xxxx/xxxx.xxxxxxxxx

doping. Therefore it is possible to develop a fully transparent ReRAM based on ZnO. The switching mechanisms of ZnO ReRAM are mainly attributed to the formation/rupture of defect-based conductive nanofilaments near the electrode/metal oxide interface, which is greatly influenced by the chemisorbed O₂ molecules at the surfaces [3]. A great effort has been made to eliminate the detrimental surface effect on the resistive memory switching. It has been reported that by introducing transparent graphene electrodes as a passivation layer, the detrimental surface effect can be eliminated [4]. He et al. had reported that surface modification of ZnO resistive memory via fluorine and nitrogen doping to replace the oxygen sites leads to superior performance uniformity [5]. However, these optimization methodologies come with additional cost and complexity of fabrication process. Hence, a simple, scalable and cost-effective fabrication method for eliminating the surface effect is needed for practical application of resistive oxide memory.

In this work, the influences of surface roughness on the electrical property of ZnO ReRAM were carefully investigated. Other than the chemical modification, the physical method of glancing angle deposition (GLAD) was employed to modify the surface roughness of ZnO. It demonstrates that the ZnO-based ReRAM with rough surface possess higher resistive switching probability and are more stable in SET/RESET switching voltage and HRS resistance for various ambience conditions. Furthermore, from the measurement results of field effect transistors (FETs), smaller variation of threshold voltage (V_{th}) is observed for ZnO with rough surface under various ambience conditions. It shows that the change in oxygen adatoms $(O_{2(ad)}^{-})$ concentration is insignificant at the rough surface which, in turn, leads to a stable electrical property of ZnO. These observations advance the understanding of surface effects and provide valuable insights for future optimization of ReRAM devices.

II. EXPERIMENT

100-nm-thick ZnO thin films were deposited on the Pt/Cr/SiO₂/Si substrates at room temperature (RT) by rf magnetron sputtering with an O_2 working pressure of 6×10^{-1} Pa and power of 100 W using a Zn target. The GLAD with an angle of 70° and 20 min deposition was employed to modify the surface roughness of ZnO. Surface modification by the GLAD had been reported in the literatures [6]. During the GLAD, the deposition power and pressure are 100 W and 6×10^{-1} Pa, respectively. In order to measure the electrical properties of the ZnO films, the top electrodes Pt with thickness of 100 nm were deposited on the ZnO using DC sputtering. To investigate the

ambient influences on the electrical property, 25 cells were evaluated at RT under air or vacuum condition (10⁻⁵ Torr). Morphology and roughness of the ZnO surface were investigated by atomic force microscopy (AFM). The back-gate FET configuration measurements (Pt/ZnO/SiO₂/n⁺-Si) were also prepared to study the oxygen chemisorption on the ZnO surface.

III. RESULTS AND DISCUSSION

distinguish interface and bulk effects, thickness-dependent electrical properties of initial state (IS), HRS and LRS were investigated. As shown in Fig. 1(a), the resistance of IS increases with the thickness of ZnO films. The IS of ZnO ReRAM behaves as conventional ZnO-based devices, which consists of ZnO thin films and electrode/ZnO interface connected in series [7]. Hence, the total resistance of ZnO ReRAM can be obtained by the sum of the resistances of bulk ZnO and electrode Pt/ZnO interface. On the other hand, the resistances of high resistance state (HRS) and low resistance state (LRS) are thickness-independent. The ReRAM switching property relies on the formation/rupture of the conductive nanofilament built by the V₀ [4,8,9]. As the ZnO ReRAM devices were electroformed, the metallic conductive nanofilament dominates the electrical transport within the ZnO bulk, leading to the thickness independence on HRS and LRS resistance, which indicates that the switching process relies on the resistance changes near the Pt/ZnO interface [7], as shown in Fig. 1(b). It shows that the interface plays an important role in the resistive switching functionality.

To study the influences of Pt/ZnO interface on the ZnO ReRAM characteristics, the switching probability was measured under various ambience and surface roughness conditions. Fig. 2 illustrates schematic and corresponding AFM image of ZnO with flat and rough surfaces. For the ZnO with flat surface, the root-mean-square (RMS) and max roughness are 2.23 and 16.5, respectively. On the other hand, RMS and max roughness for the rough ZnO surface are 4.98 and 32.3, indicating a rough surface. As shown in Fig. 3(a), ZnO ReRAM

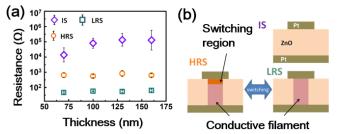


Fig. 1 (a) Thickness dependence of initial state (IS), HRS and LRS. (b) The resistive switching process of ZnO resistive memory devices.

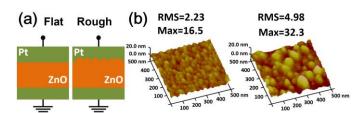


Fig. 2. (a) Schematics of device structure and (b) AFM images of flat and rough surface condition.

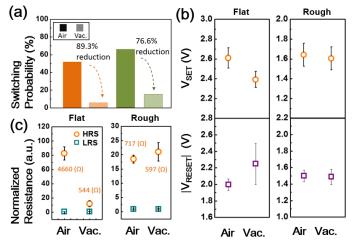


Fig. 3. (a) Resistive switching probability, (b) SET/RESET voltage and (c) normalized resistance for the flat and rough surface condition under the air and vacuum ambience.

with rough surface has higher switching probability. The higher switching probability of ZnO with rough surface can be attributed to larger interface area, which leads to the more $O_{2(ad)}^-$ absorption. It had been shown that higher $O_{2(ad)}^-$ concentration leads to better switching functionality [3]. Furthermore, it can also be observed that the switching probability in air ambience is much better than that under vacuum condition, which can also be attributed to the higher $O_{2(ad)}^-$ concentration in air ambience. Additionally, the rough surface condition has stable switching probability against various ambience conditions, which indicates that metal oxide memory with rough surfaces is more suitable to operate as the environment is changed rapidly. The relevant mechanism will be discussed later.

Fig. 3(b) shows the SET/RESET switching voltage of ReRAM with different surface under air and vacuum conditions. For the flat surface condition, the RESET switching voltage measured in the air ambience is lower than that under vacuum condition. It can be attributed to the fact that in the air ambience, the high concentration of $O_{2(ad)}^-$ increases the annihilation probability of Vo's, and thus the required RESET voltage is reduced as compared with that under vacuum condition. Note that the significant effect of $O_{2(ad)}^-$ on annihilation of Vo's and on the formation/rupture of conductive nanofilaments had been previously demonstrated in the literature [3]. Oppositely, the SET process relies on the generation of the V_0 's. Thus the SET voltage is low under vacuum due to the low concentration of $O_{2(ad)}^-$. As for the ReRAMs with rough surface, the electrical property is stable in various ambiences, compared to that with flat surface condition. Nanoscale rough surfaces would create more surface states with more dangling bonding, implying more complex and stronger bonding to $O_{2(ad)}^-$. Accordingly, the ZnO ReRAMs with rough surface show relatively invariant SET and RESET voltages.

Fig. 3(c) shows the HRS and LRS resistance for both flat and rough surface conditions. Note that HRS resistance is normalized to its corresponding LRS resistance in the figure for

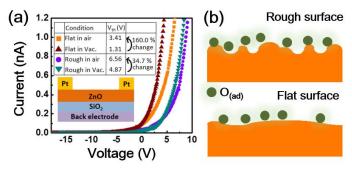


Fig. 4. (a) The transfer characteristics of the ZnO FET with various surface and measuring ambience conditions. The inset in (a) is FET measuring configuration. (b) A schematic of oxygen chemisorption process on the rough and flat surface.

a comparison. It is clear that for the flat surface condition, HRS resistance is ambience-dependent. Indeed, in the air ambience, more $O_{2(ad)}^-$ are chemisorbed on the ZnO surface. The oxygen adsorption leads the band bending of the ZnO surface, which results in the increase of surface resistance. On the other hand, no ambience-dependent resistance is observed in the LRS. It can be attributed to the fact that the metallic behavior of the conductive nanofilament is not affected by the oxygen chemisorption. Comparing switching voltage and resistance for both surface conditions, the ZnO ReRAMs with rough surface show relatively invariant HRS values as the ambience is changed, which is consistent to the results of SET and RESET voltages shown in Fig. 3(b).

To further confirm the electrical stability of ZnO ReRAM with rough surface, the electrical characteristics of ZnO FET configuration (inset of Fig. 4(a)) were studied. Note that, in this study, V_{th} is the linear extrapolation of I_D-V_G curve at its maximum slope. As shown in Fig. 4(a), for both surface conditions, the V_{th} of ZnO under vacuum condition is smaller than that in the air ambience. This is because that the $O_{2(ad)}^$ concentration on the surface of ZnO under air condition is greater than that under vacuum condition. The higher $O_{2(ad)}^$ concentration leads to larger chemisorption-induced band bending which requires higher gate voltage to compensate and hence results in higher V_{th} [1]. In addition, the ZnO with rough surface absorbs more oxygen adatoms due to the larger surface area leading to the larger V_{th} than ZnO with flat surface, as shown in Fig. 4(b). Fig. 4(a) also shows that the difference of V_{th} between air and vacuum ambience under rough surface condition is less than that under flat surface condition. This indicates that the variation of $O_{2(ad)}^-$ concentration absorbed on the rough ZnO surfaces is much small between air and vacuum ambience, which is consistent with the experimental observation from the memory characterizations (Fig. 3).

IV. CONCLUSION

In summary, we demonstrated that the surface roughness has significant impact on memory characteristics of ReRAM. The ZnO ReRAM with rough surfaces shows superior switching probability and stable characteristics against various ambience conditions. The underlying mechanism is ascribed to the roughness-enhanced absorption on oxide surfaces, which leads

to the improvement of chemisorption-assisted switching process. These findings not only provide further insights to the surface effect on memory switching behaviors but also help in developing stable and uniform ReRAMs for practical applications.

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